



AMENDMENT UNDER 37 C.F.R. § 1.116  
EXPEDITED PROSECUTION - GROUP ART UNIT 2874

3500.013974

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
: Examiner: Davienne Monbleau  
TADAHIRO OHMI ET AL. )  
: Group Art Unit: 2874  
Application No.: 09/425,015 )  
: Filed: October 25, 1999 )  
: For: GAS SUPPLY PATH )  
STRUCTURE FOR A GAS LASER :  
METHOD, LASER ) October 16, 2002

Commissioner for Patents  
Box: AF  
Washington, D.C. 20231

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the Office Action dated July 16, 2002, please amend  
the above-identified application as follows and consider the following remarks.

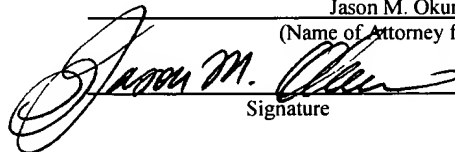
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October 16, 2002

(Date of Deposit)

Jason M. Okun

(Name of Attorney for Applicants)

  
Signature

October 16, 2002  
Date of Signature

AF  
2874  
#13 B (AK)  
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